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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Attn: OIPE

Tatsuo ITO et al.

Group Art Unit: 2125

Application No.: 10/502,389

Docket No.: 120503

Filed: July 26, 2004

For: METHOD FOR MANUFACTURING SEMICONDUCTOR WAFER, METHOD FOR RECEIVING ORDER FOR MANUFACTURE OF SEMICONDUCTOR WAFER, AND SYSTEM FOR RECEIVING ORDER FOR MANUFACTURE OF SEMICONDUCTOR WAFER

SECOND REQUEST FOR CORRECTION OF PALM RECORDS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

A Request for Correction of PALM Records was filed on January 5, 2005 to request correction of the title of the application. A copy of the first Request for Correction of PALM Records with the marked-up OFR is attached hereto. A copy of the stamped receipt for filing the first Request for Correction of PALM is also attached. A Corrected Filing Receipt Status Request was filed on April 21, 2005. A copy of the stamped receipt is attached hereto. Upon further review of PALM, the title remains incorrect. The correct title is "METHOD FOR MANUFACTURING SEMICONDUCTOR WAFER, METHOD FOR RECEIVING ORDER FOR MANUFACTURE OF SEMICONDUCTOR WAFER, AND SYSTEM FOR RECEIVING ORDER FOR MANUFACTURE OF SEMICONDUCTOR WAFER."

It is respectfully requested that the corrected Filing Receipt be immediately forwarded to the attorneys of record at the address set forth below.

If there are any questions regarding this matter, please contact the undersigned at the telephone number set forth below.

Respectfully submitted,



William P. Berridge
Registration No. 30,024

Donald A. DiPaula
Registration No. 58,115

WPB:DAD/hjr

Date: June 30, 2006

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

**DEPOSIT ACCOUNT USE
AUTHORIZATION**

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Charge any fee due to our
Deposit Account No. 15-0461

PTO RECEIPT FOR FILING OF PAPERS

► **Mail Room (Regular Delivery)**

The following papers have been filed:

Request for Correction of PALM Records; Marked-up OFR

Name of Applicant: Tatsuo ITO et al.

Serial No.: 10/502,389

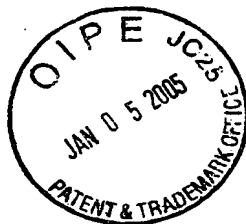
Atty. File No.: 120503

Title (New Cases):

Sender's Initials: JAO/cqc

181/23

PATENT OFFICE DATE STAMP



**COPY TO BE STAMPED BY PATENT OFFICE
AND RETURNED BY MESSENGER**

**Oliff & Berridge, PLC
277 S. Washington Street, Suite 500, Alexandria, Virginia 22314**



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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Attn: OIPE

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SEMICONDUCTOR WAFER

REQUEST FOR CORRECTION OF PALM RECORDS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records.

Respectfully submitted,

James A. Oliff
Registration No. 27,075

Eric D. Morehouse
Registration No. 38,565

JAO:EDM/cqc

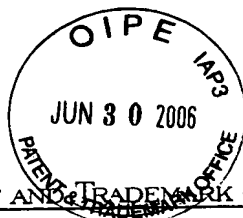
Date: January 5, 2005

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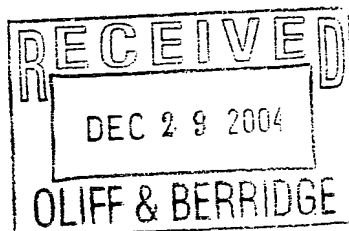
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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/502,389	07/26/2004	2812	1190	120503	6	35	3

25944
OLIFF & BERRIDGE, PLC
P.O. BOX 19928
ALEXANDRIA, VA 22320



CONFIRMATION NO. 3456

FILING RECEIPT



OC000000014830077

Date Mailed: 12/28/2004

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Tatsuo Ito, Tokyo, JAPAN;
Shigeyoshi Netsu, Fukushima, JAPAN;
Masashi Ichikawa, Fukushima, JAPAN;
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Power of Attorney:

Thomas Pardini-30411

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP03/00557 01/22/2003

Foreign Applications

JAPAN 200219334 01/29/2002

Projected Publication Date: 04/07/2005

Non-Publication Request: No

Early Publication Request: No

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Title

~~Semiconductor wafer manufacturing method, semiconductor wafer manufacturing order acceptance method, and semiconductor wafer manufacturing order acceptance system~~

Preliminary Class
438

Method for Manufacturing Semiconductor Wafer, Method
for Receiving Order for Manufacture of Semiconductor
Wafer, and System for Receiving Order for Manufacture of
Semiconductor Wafer

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Title 35, United States Code, Section 184

Title 37, Code of Federal Regulations, 5.11 & 5.15

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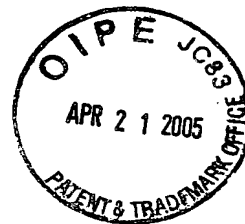
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The following papers have been filed:

Corrected OFR Status Request; copy date stamped receipt; copy of Request for Correction of PALM Records

Name of Applicant: Tatsuo ITO et al.

Serial No.: 10/502,389

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